PLEASE ENTER THE AFTER FINAL AMENDMENT DATED DECEMBER 28, 2009. /KQ/

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of : Attorney Docket No. 2004 0347A

Toshiyuki TAKIZAWA : Confirmation No. 3118

Serial No. 10/790,864 : Group Art Unit 2826

Filed March 3, 2004 : Examiner Kevin V. Quinto

P-TYPE SEMICONDUCTOR AND : Mail Stop: AF

SEMICONDUCTOR HETERO MATERIAL AND MANUFACTURING METHODS

THEREOF

AMENDMENT AFTER FINAL OFFICE ACTION

Commissioner for Patents

P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

In response to the Office Action of October 15, 2009, please amend the above-identified U.S. Patent application as follows.